

Form PTO-1449

(MODIFIED)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.

039153-298 (F0785)

SERIAL NO.

09/819,343

APPLICANT

Calvin T. Gabriel et al.

FILING DATE

03/28/2001

GROUP ART UNIT

1746

## INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
118	A1	6,232,048	5/15/2001	Buynoski et al.	430	328	
118	A2	6,197,687	3/6/01	Buynoski	438	328	671.
118	A3	6,110,837	8/29/00	Linliu et al.	438	723	
118	A4	5,876,903	3/2/99	Ng et al.	420	313	
118	A5	5,468,595	11/21/95	Livesay	420	296	
118	A6	3,997,367	12/14/1976	Yau	148	15	

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


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118 [signature]

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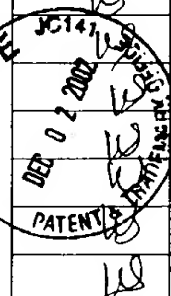
4/30/03

- \* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.

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<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				APPLICANT Calvin T. Gabriel et al.				
				FILING DATE 03/28/2001		GROUP ART UNIT 1746		
<b>U.S. PATENT DOCUMENTS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE	
WJ	A1	6,197,687	3/06/2001	Buynoski	478	671		
WJ	A2	5,994,225	11/30/99	Liu et al.	478	313		
WJ	A3	5,876,903	3/02/99	Ng et al.	478	295		
WJ	A4	5,468,595	11/21/1995	Livesay	478	295		
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
WJ	A5	Chiong K.G. et al. "Resist Contrast Enhancement in High Resolution Electron Beam Lithography", Journal of Vacuum Science and Technology: Part B, American Institute of Physics, New York, US, vol. 7, no. 6.						
WJ	A6	Patent Abstracts of Japan, vol 1999, no. 09, 30 July 1999 (1999-07-30) & JP 11 097328 A (Toshiba Corp), 9 April 1999 (1999-04-09) abstract						
EXAMINER WJ Weger				DATE CONSIDERED 4/20/03.				
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<b>INFORMATION DISCLOSURE CITATION</b>  (Use several sheets if necessary)		APPLICANT Calvin T. Gabriel et al.	
		FILING DATE 03/28/2001	GROUP ART UNIT 1746

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
	A1	6,420,097	07/16/2002	Pike et al.	430	313	
	A2	6,395,447	05/28/2002	Ishii et al.	430	191	
	A3	6,358,670	03/19/2002	Wong et al.	430	296	
	A4	6,319,655	11/20/2001	Wong et al.	430	311	
	A5	6,174,818	01/16/2201	Tao et al.	438	733	
	A6	4,446,222	05/01/1984	Kress	430	307	
	A7	4394,211	07/19/1983	Uchiyama et al.	156	628	

**FOREIGN PATENT DOCUMENTS**

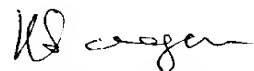
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


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